

EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
S1	13	"6,369,957"	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	AND	ON	2007/07/18 10:08
S2	18697	Optical same lithography	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	AND	ON	2007/07/18 10:54
S3	3	S2 and (solid adj immersion adj lens near2 layer)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	AND	ON	2007/07/18 10:16
S4	3	S2 and (immersion adj lens near2 layer)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	AND	ON	2007/07/18 10:49
S5	209	S2 and (lens near2 layer)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	AND	ON	2007/07/18 10:51
S6	3	S5 and (solid adj immersion adj lens near2 layer)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	AND	ON	2007/07/18 10:20
S7	10	S5 and (layer near4 movement)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	AND	ON	2007/07/18 10:52

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S8	0	(helmar-van-santen).IN.	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	AND	ON	2007/07/18 10:37
S9	0	(santen-van-h).IN.	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	AND	ON	2007/07/18 10:38
S10	19	(santen-h-v).IN.	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	AND	ON	2007/07/18 10:46
S11	103	S5 and (gas near4 removal or flow)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	AND	ON	2007/07/18 10:46
S12	6	S11 and (layer near4 movement)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	AND	ON	2007/07/18 10:48
S13	14517	((250/492.10,216,234,235,) or (359/619,581,) or (369/44.14,112,) or (430/311,322,)).CCLS.	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2007/07/18 10:49
S14	5	S13 and (immersion adj lens near2 layer)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	AND	ON	2007/07/18 10:49

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S15	103	S11 and (lens near2 layer)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	AND	ON	2007/07/18 10:51
S16	6	S15 and (layer near4 movement)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	AND	ON	2007/07/18 10:52
S17	0	(optical same lithography) and (solid adj immersion adj lens near4 layer) and (layer near4 movement) and (irrad\$5 near4 portions or segments) and (liquid near4 interspace) and (remov\$3 near4 liquid) and (remov\$3 or displace near4 gas adj flow).clm.	US-PGPUB; USPAT	AND	ON	2007/07/18 10:58